



Application of:

: Confirmation No. 5389

Jack Oon Chu et al.

: Group Art Unit: 2815

Serial No.:

09/769,170

: Examiner: E.J. Wojciechowicz

Filed:

Jan. 25, 2001

: Date:

May 20, 2002

For:

A TRANSFERABLE

DEVICE-CONTAINING

LAYER

FOR

SILICON-ON-INSULATOR APPLICATIONS

6/26/02

Response to a Requirement for Restriction Under 37 CFR 1.142

Show

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

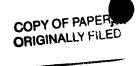
In response to the requirement for restriction under 35 U.S.C. 121 mailed Jan. 03, 2002, applicants' attorney elects the claims in Group II, claims 1-30, drawn to a semiconductor device, for prosecution on the merits. The election is made without traverse.

The claims in Group I, claims 31-40, drawn to a method of making a semiconductor device, are hereby withdrawn from further prosecution.

Further favorable action and allowance of the elected claims is earnestly requested.

Attorney Docket No.: YOR920000692US1





Respectfully submitted, Attorney for the Applicant(s)

by

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